

Docket No.: 50090-339

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PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Takashi INBE

Serial No.: 09/960,356

Filed: September 24, 2001

For: SEMICONDUCTOR DEVICE FOR DETECTING NEUTRON, AND METHOD FOR THE FABRICATION

: Response Under 37 CFR 1.116 - Expedited Procedure

: Group Art Unit: 2811

: Examiner: Gene Munson

Box AF
THE COMMISSIONER FOR PATENTS AND TRADEMARKS
Washington, DC 20231

Dear Sir:

Transmitted herewith is an Amendment in the above identified application.

- ☐ No additional fee is required.
☐ Applicant is entitled to small entity status under 37 CFR 1.27
☐ Also attached:

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	3	29	0	\$18.00 =	\$0.00
Independent Claims	2	4	0	\$84.00 =	\$0.00
Multiple claims newly presented					\$0.00
Fee for extension of time					\$110.00
Total of Above Calculations					\$0.00
					\$110.00

- ☒ Please charge my Deposit Account No. 500417 in the amount of \$110.00. An additional copy of this transmittal sheet is submitted herewith.
- ☒ The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

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Date: March 18, 2003

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Docket No.: 50090-339

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

: **RESPONSE UNDER 37 CFR § 1.116**

Takashi INBE

: **EXPEDITED PROCEDURE**

Serial No.: 09/960,356

: Group Art Unit: 2811

Filed: September 24, 2001

: Examiner: Gene Munson

For: SEMICONDUCTOR DEVICE FOR DETECTING NEUTRON, AND METHOD FOR THE
FABRICATION

AMENDMENT UNDER 37 CFR § 1.116

Box AF
Commissioner for Patents
Washington, DC 20231

Sir:

The following remarks and amendment are submitted in response to the Office Action

dated November 18, 2002, pursuant to 37 C.F.R. § 1.116.

This amendment is presented in accord with the Waiver of 37 C.F.R. § 1.121 published in
the Pre-OG notices on January 31, 2003.

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31 March 2003